

1 inch C-plane n-type high-transparency AMMONO-GaN substrate, oxygen-doped.
 The substrate is sliced from a mono-crystalline bulk material grown by ammonothermal method.

TECHNICAL SPECIFICATION

DESCRIPTION	UNIT	VALUE
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General specification

Orientation		(0001) C plane
Thickness	μm	350 (±50)
Dimension(s)	mm	Ø25,7 (±0,5)
Primary Flat (PF)	mm	12 (±1)
Secondary Flat (SF)	mm	8 (±1)
Bow	μm	0 (±10)
Total Thickness Variation (TTV)	μm	≤ 40

Structural specification

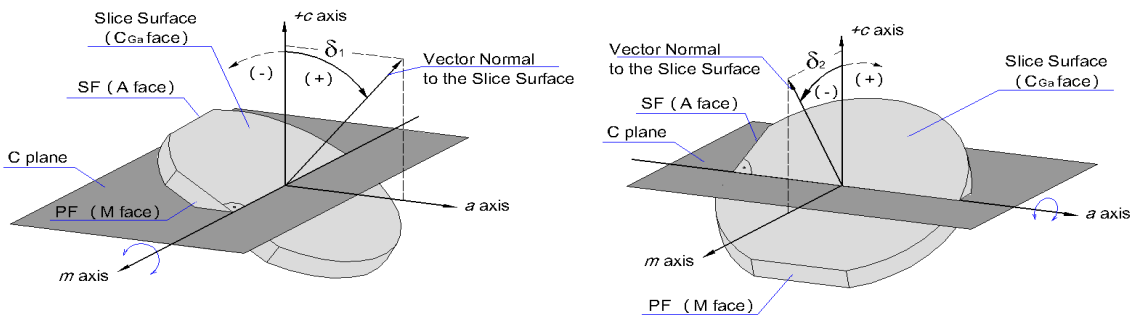
Etch Pit Density (EPD)	cm ⁻²	< 5 x 10 ⁴
FWHM (0002) of X-ray rocking curve, epi-ready surface at 100 μm x 100 μm slit	arcsec	~ 20
Macrodefects		none

Electrical specification

Type of conductivity		n type
Carrier concentration	cm ⁻³	2 x 10 ¹⁷ - 2 x 10 ¹⁸
Resistivity	Ω*cm	10 ⁻² - 10 ⁻¹
Carrier mobility	cm ² /V*s	~ 200 - 250

MISORIENTATION

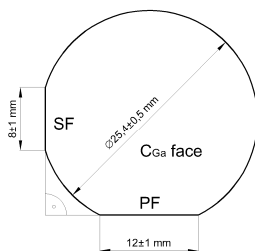
(measured in the center of the substrate)



Off M face		deg	0 (±0,25)
C face	angle δ ₁	deg	0 (±0,20)
	angle δ ₂	deg	±0,3 (±0,20)

SURFACE PREPARATION

Front side		Epi-ready polished (RMS < 0,5 nm)
Back side		Ground

SUBSTRATE SHAPE


Note: The information given above may be subject to change at any time without notice. This leaflet is not an offer within the meaning of sales or commercial law. The AMMONO-GaN substrates are offered for sale under Ammono's General Terms and Conditions.

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